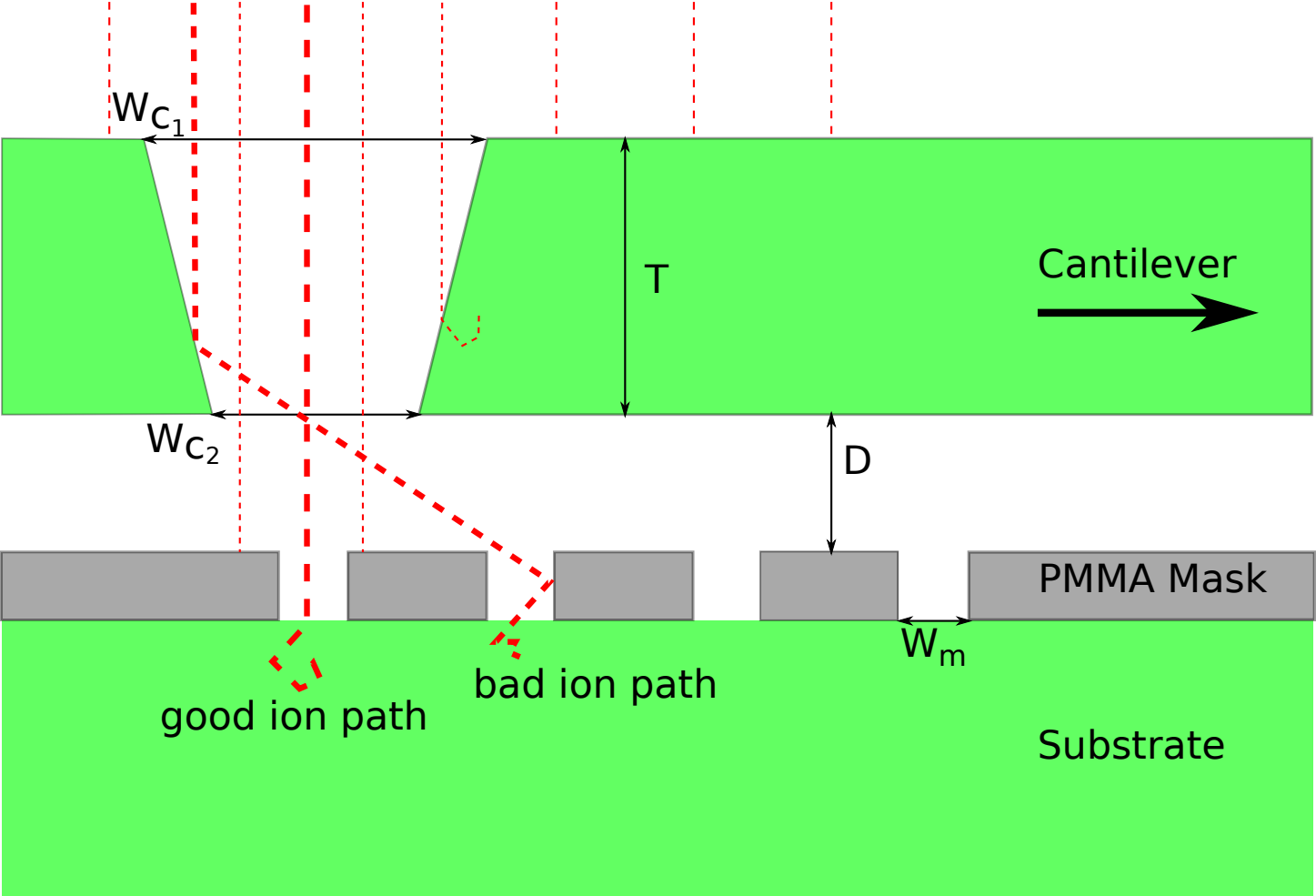

W_{c_1}
W_{c_2}
T
Cantilever
D
PMMA Mask
W_m
good ion path
bad ion path
Substrate